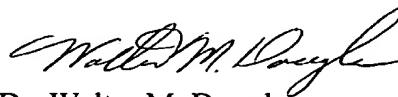


Applicants' undersigned attorney of record requests that the Examiner call if there are any matter whose resolution will facilitate prosecution of the application.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Assistant Commissioner of Patents and Trademarks, Washington, DC 20231 on <u>16 Dec 2002</u> Date of Deposit <u>Walter M. Douglas</u> Walter M. Douglas

Respectfully submitted,



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Date: 16 Dec 2002

Sheet Showing Amendment to Claims

1. A method for manufacturing an integrated optical circuit on a substrate, the substrate having a first region and a second region distinct from the first region, the method comprising the steps of:

forming a first mask on the substrate, the first mask defining a pattern corresponding to at least one optical device to be formed in the first region of the substrate;

forming a second mask on the substrate, the second mask defining a pattern corresponding to an optical structure to be formed in the second region of the substrate; [and]

etching the substrate having simultaneously thereon the first and second masks, without eroding said first and second masks, in order to form at least one optical device and the optical structure on the substrate.